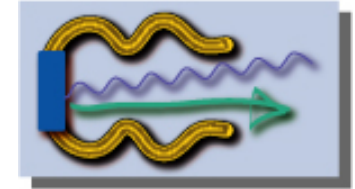


The PHIN Photoinjector for CTF3

R. LOSITO - CERN
CARE 05, 23/11/2005



Acknowledgements

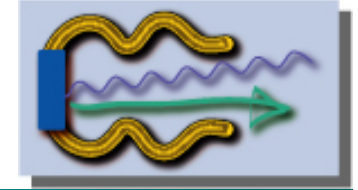


- We acknowledge the support of the European Community-Research Infrastructure Activity under the FP6 “Structuring the European Research Area” programme (CARE, contract number RII3-CT-2003-506395).





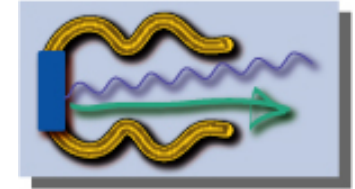
OUTLINE



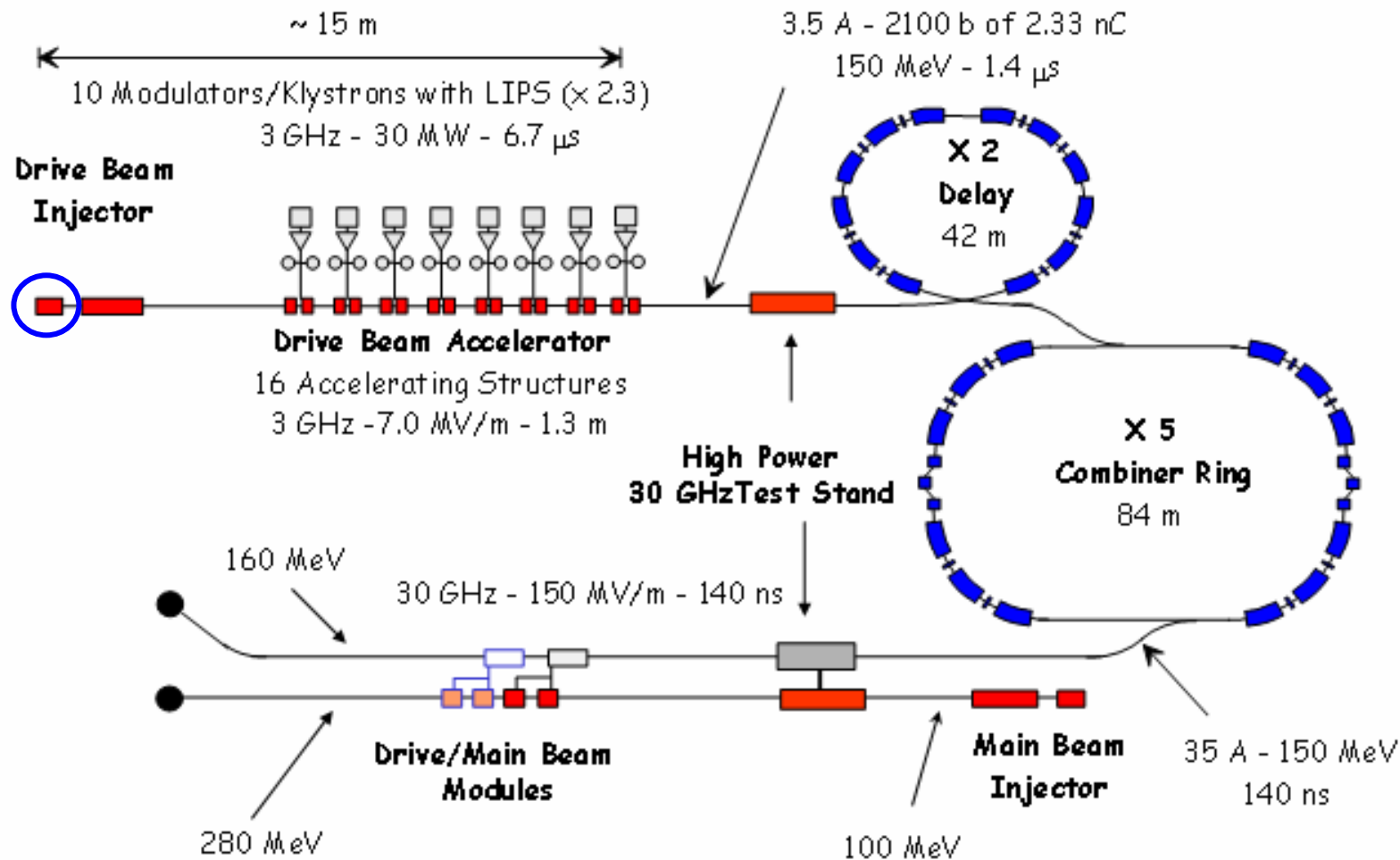
- CTF3 overview
- Photoinjector specs and design
- Laser (RAL)
- RF Gun (LAL)
- Photocathodes (CERN)
- Putting all together
- Conclusions



CTF3 overview

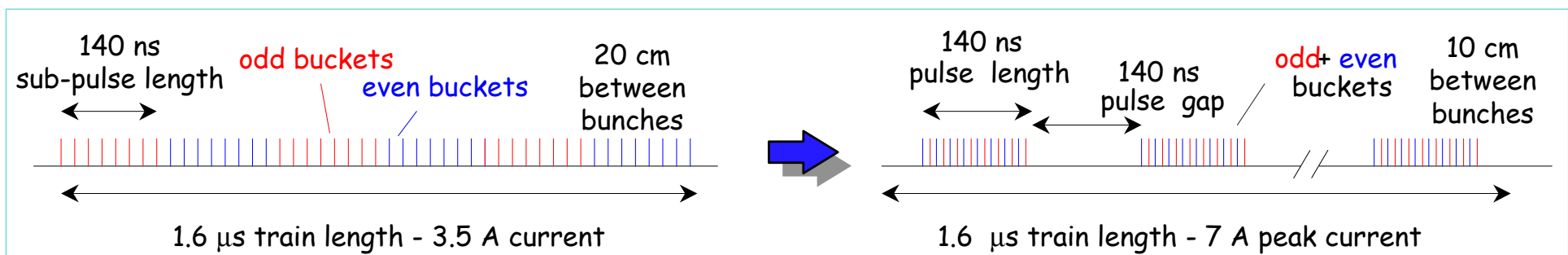
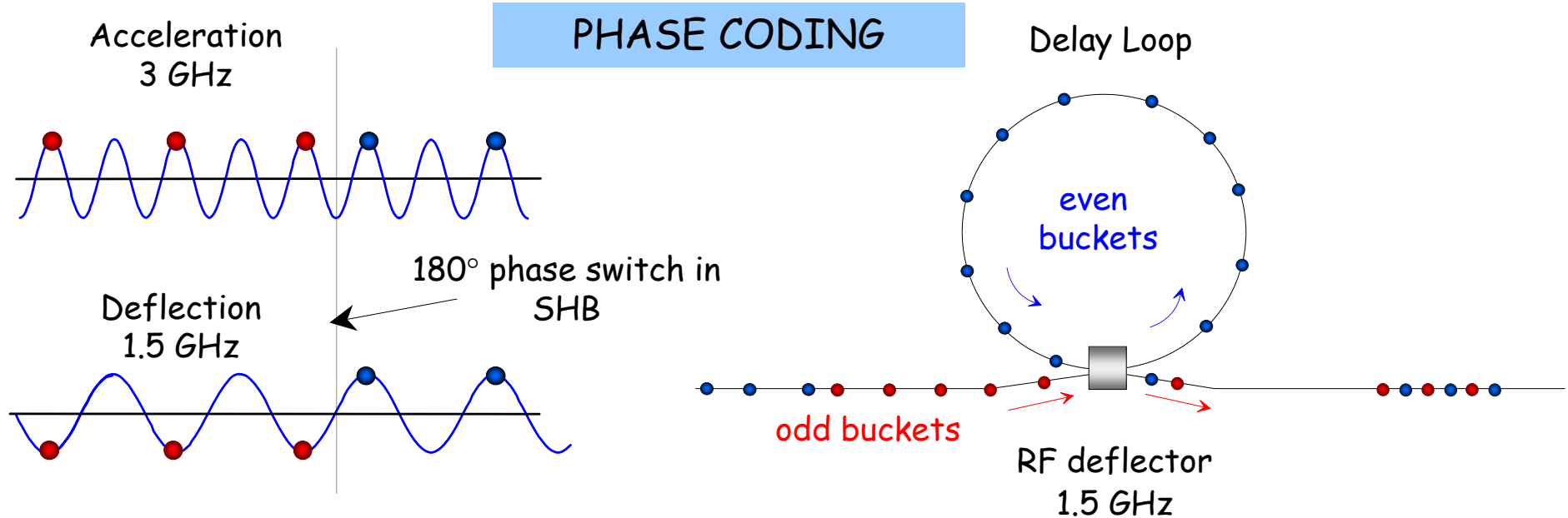
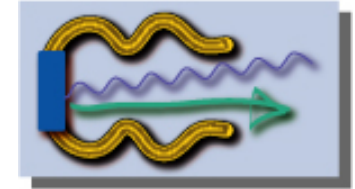


CTF3 - Test of Drive Beam Generation, Acceleration & RF Multiplication by a factor 10



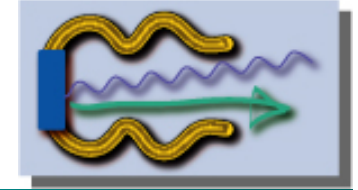


CTF3 overview





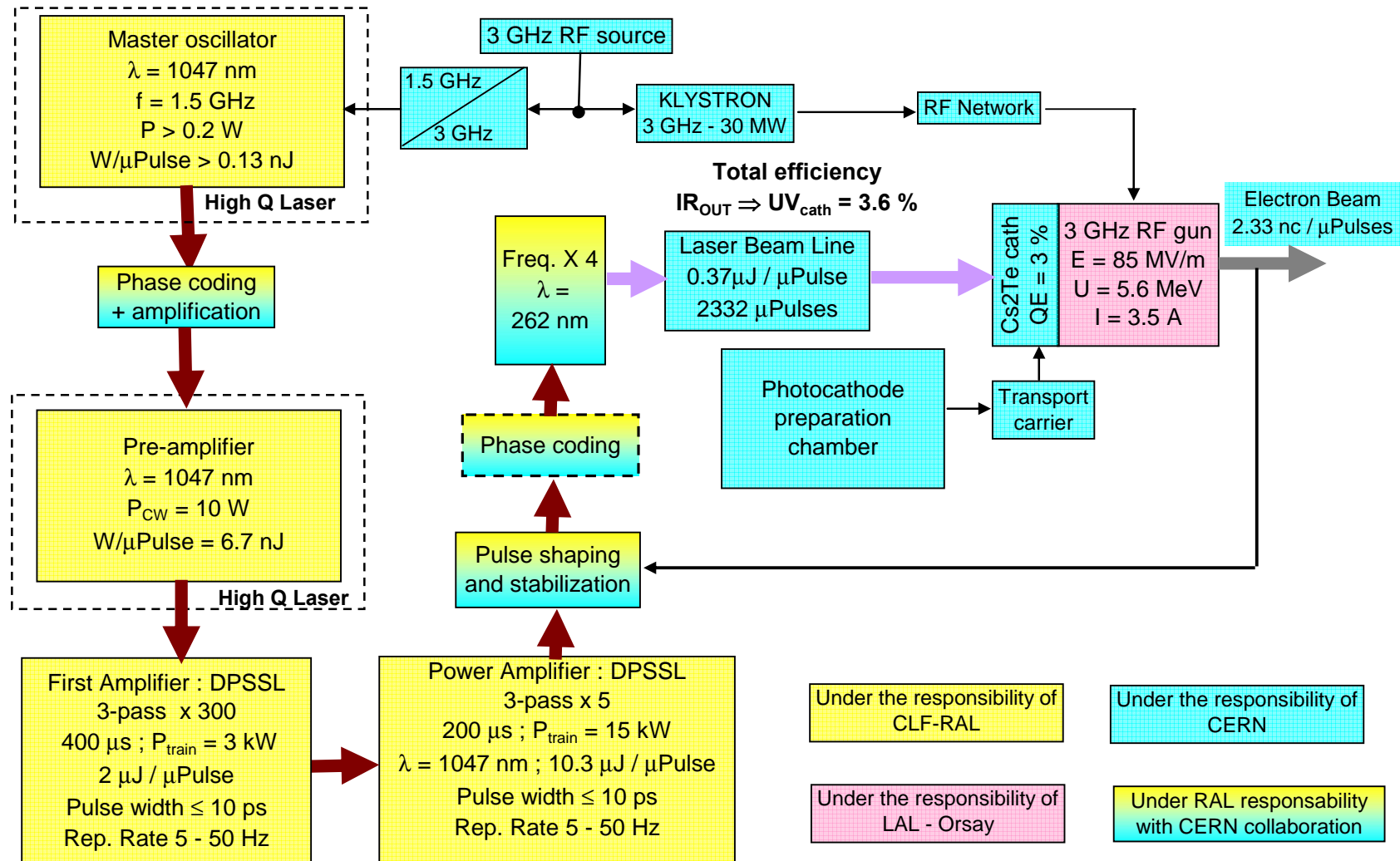
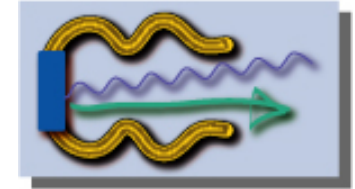
CTF3 overview



- Photoinjector Specifications:
 - ◆ Current in the train: 3.5 Amps
 - ◆ Charge in each pulse: 2.33 nC
 - ◆ Pulse frequency: 1.5 GHz
 - ◆ Rep rate: 1÷50 Hz (nominal: 5 Hz)

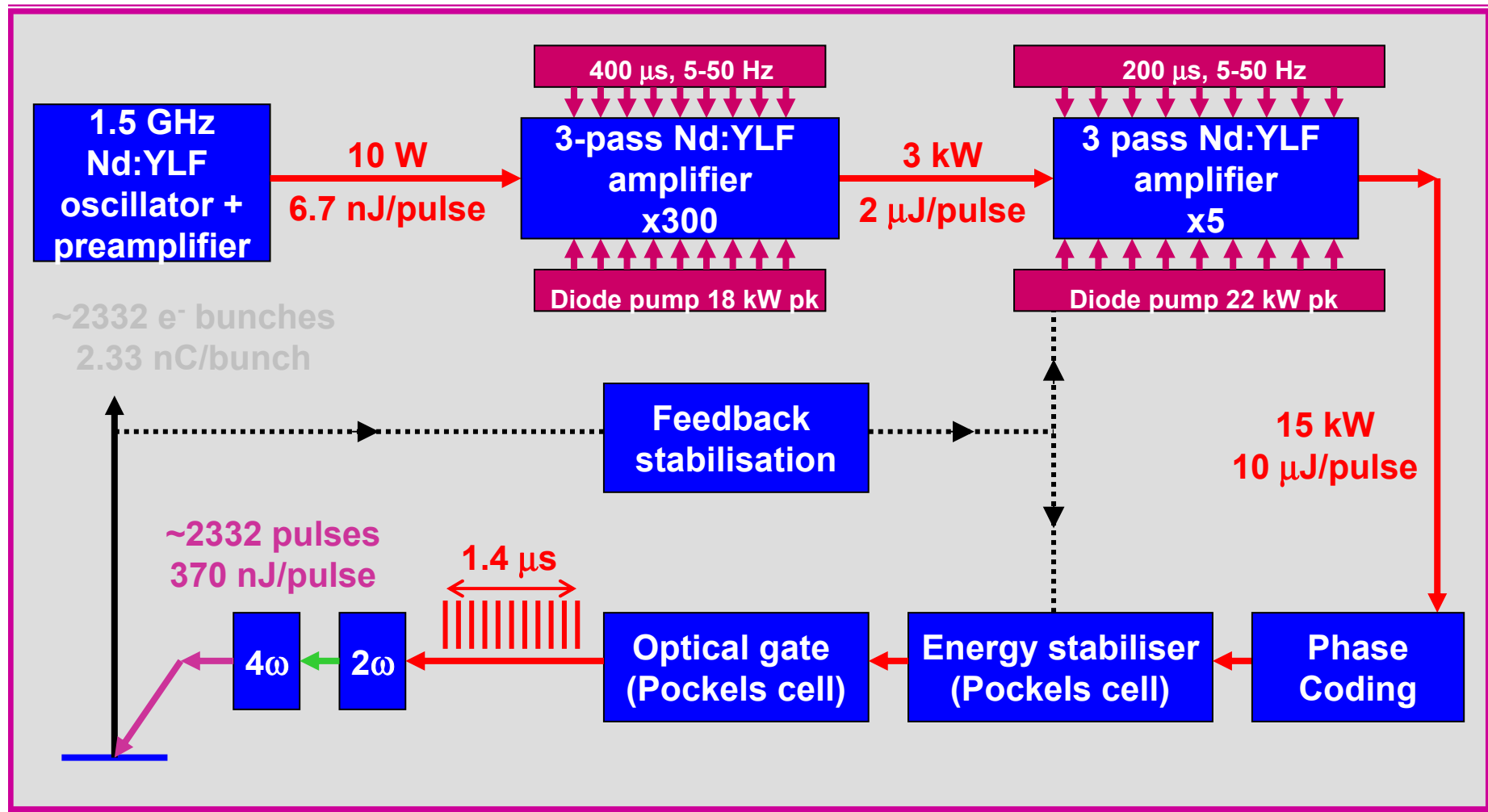
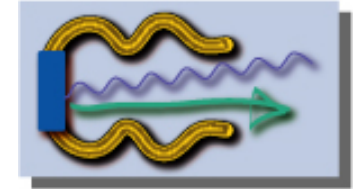


PHIN overview



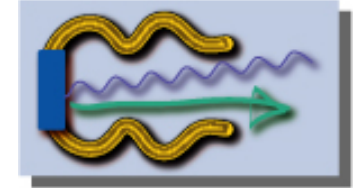


LASER





LASER



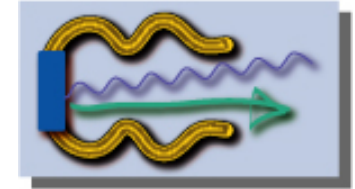
■ Oscillator :

- ◆ Oscillator frequency increased from 250 MHz (CTF2) to 1.5 GHz thanks to availability of SESAM (SEmiconductor SAturable Mirror) technology for passive mode locking of the oscillator.
- ◆ This technology allows well controlled pulse-to pulse jitter, and very good amplitude stability (<1%), on long term and from pulse to pulse.
- ◆ Acceptance tests have shown full agreement with specifications.

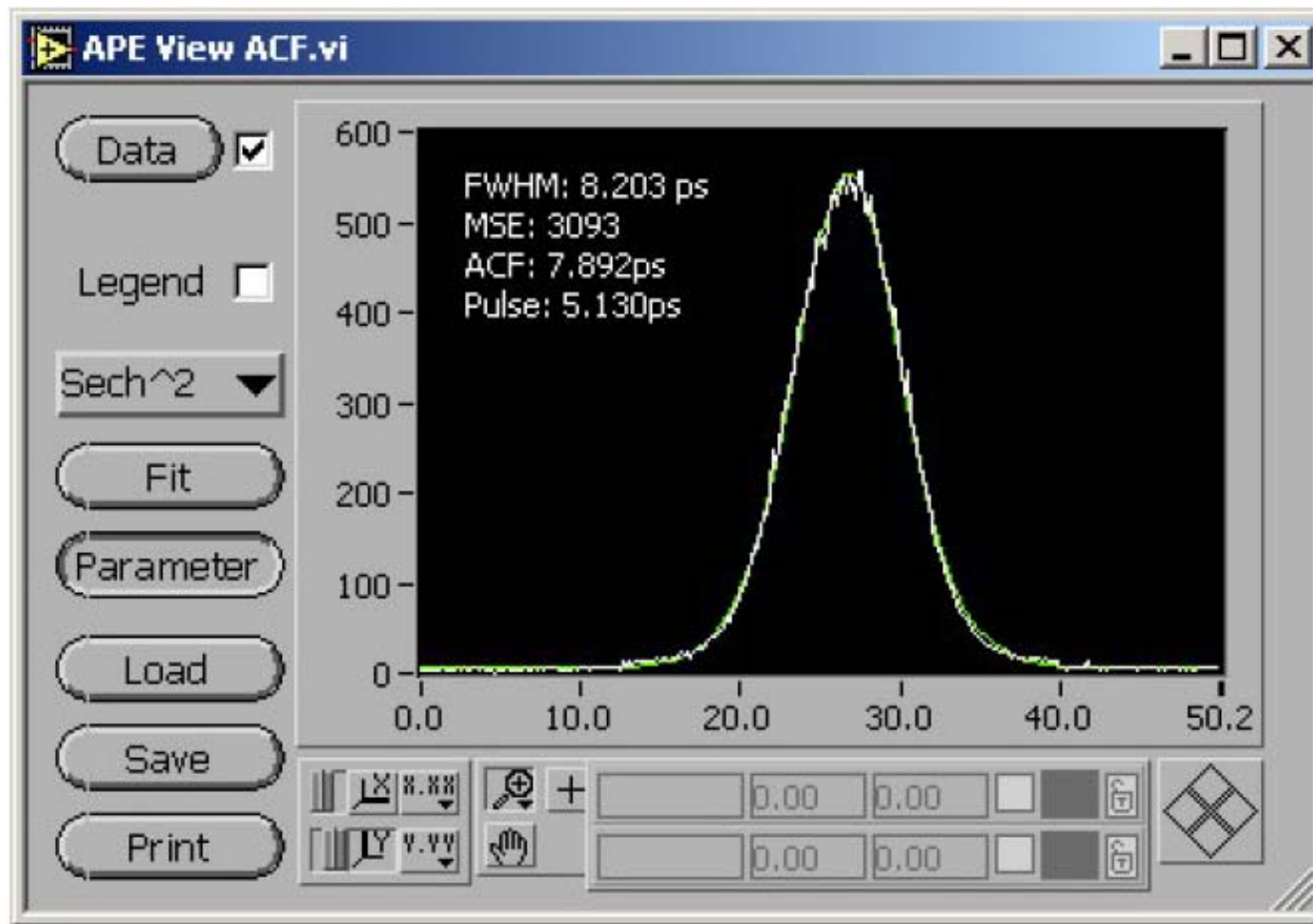




LASER

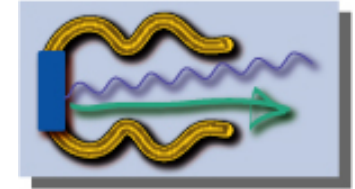


- Pulse duration measured with APE autocorrelator





LASER



Optical and electronic phase stability measurements

Measured from error signal

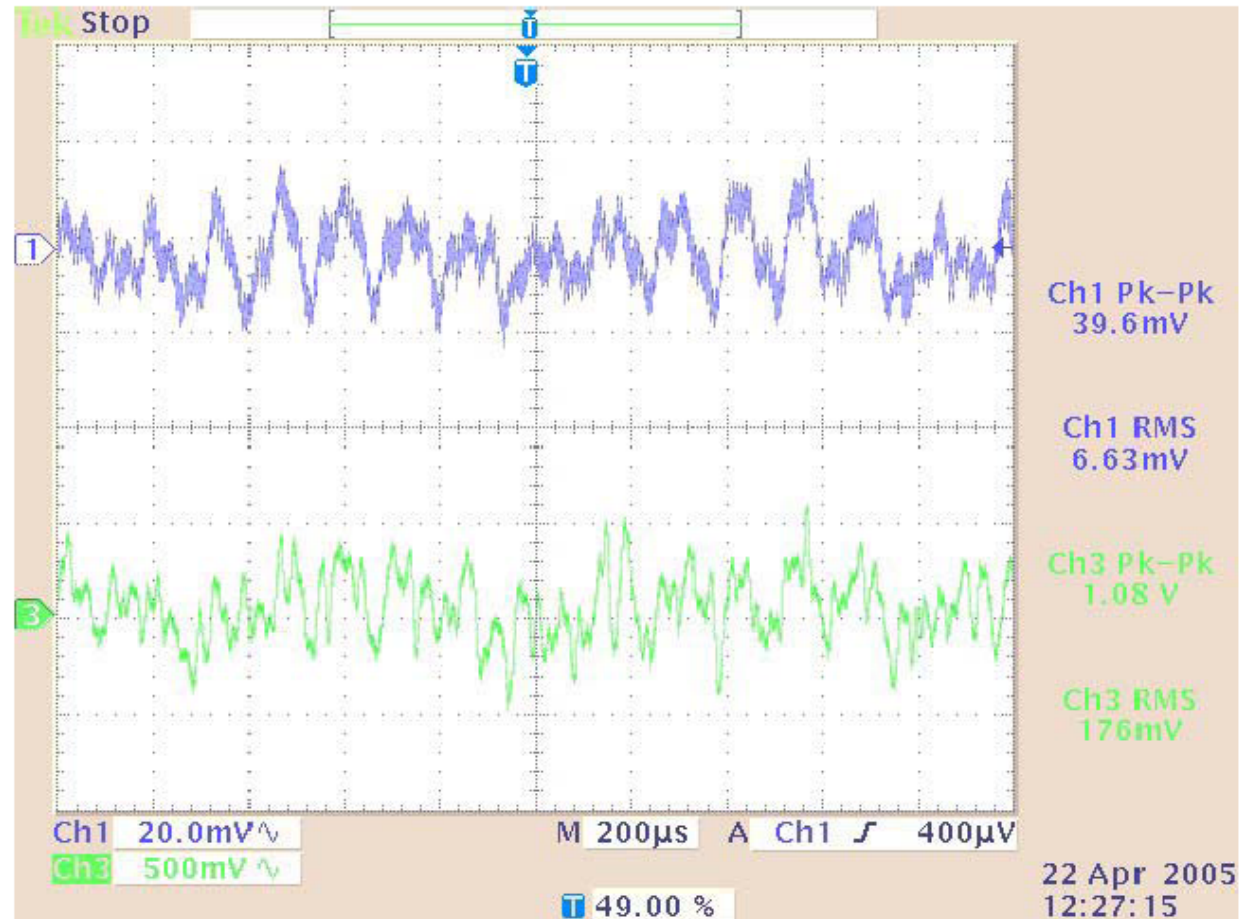
$$Jitter_{pk-pk} = 733 fs$$

$$Jitter_{rms} = 122.8 fs$$

Measured with Xcorrelation

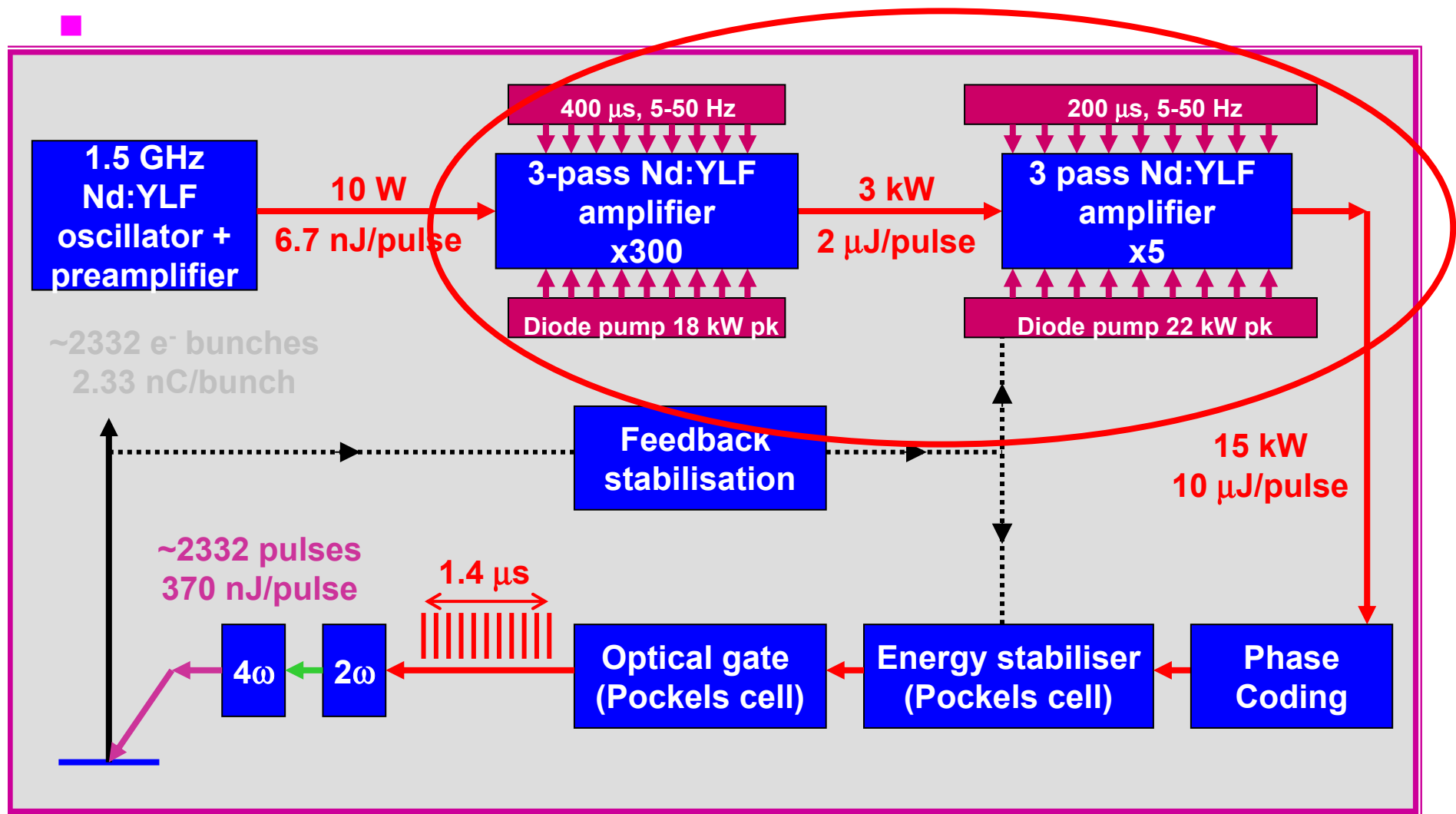
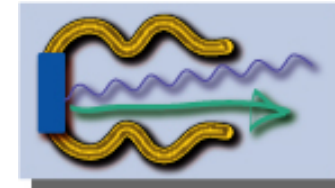
$$Jitter_{pk-pk} = 771 fs$$

$$Jitter_{rms} = 125.7 fs$$



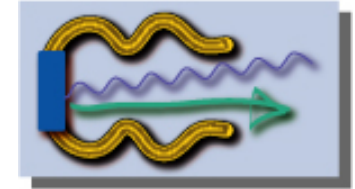


LASER



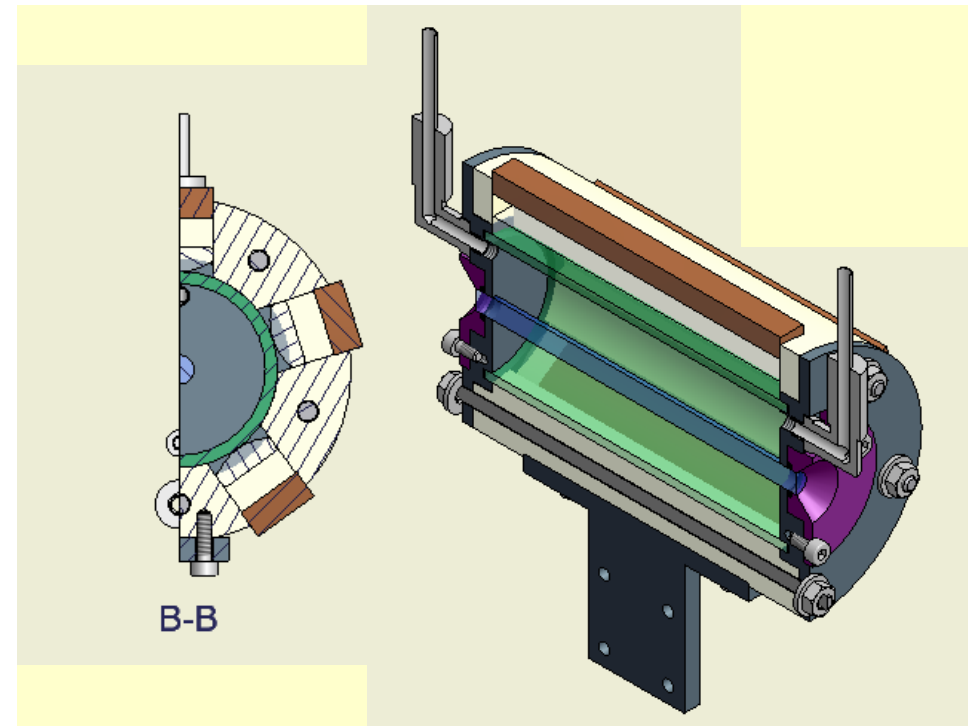


LASER



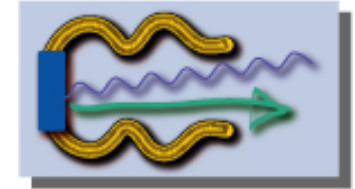
■ Mechanical Assembly for the amplifiers heads

- Easy connections of water and Electrical plugs
- Accurate positioning of the focusing optics
- Easy assembly
- Possibility of rotating the rod in situ
- Similar design for the two amplifiers

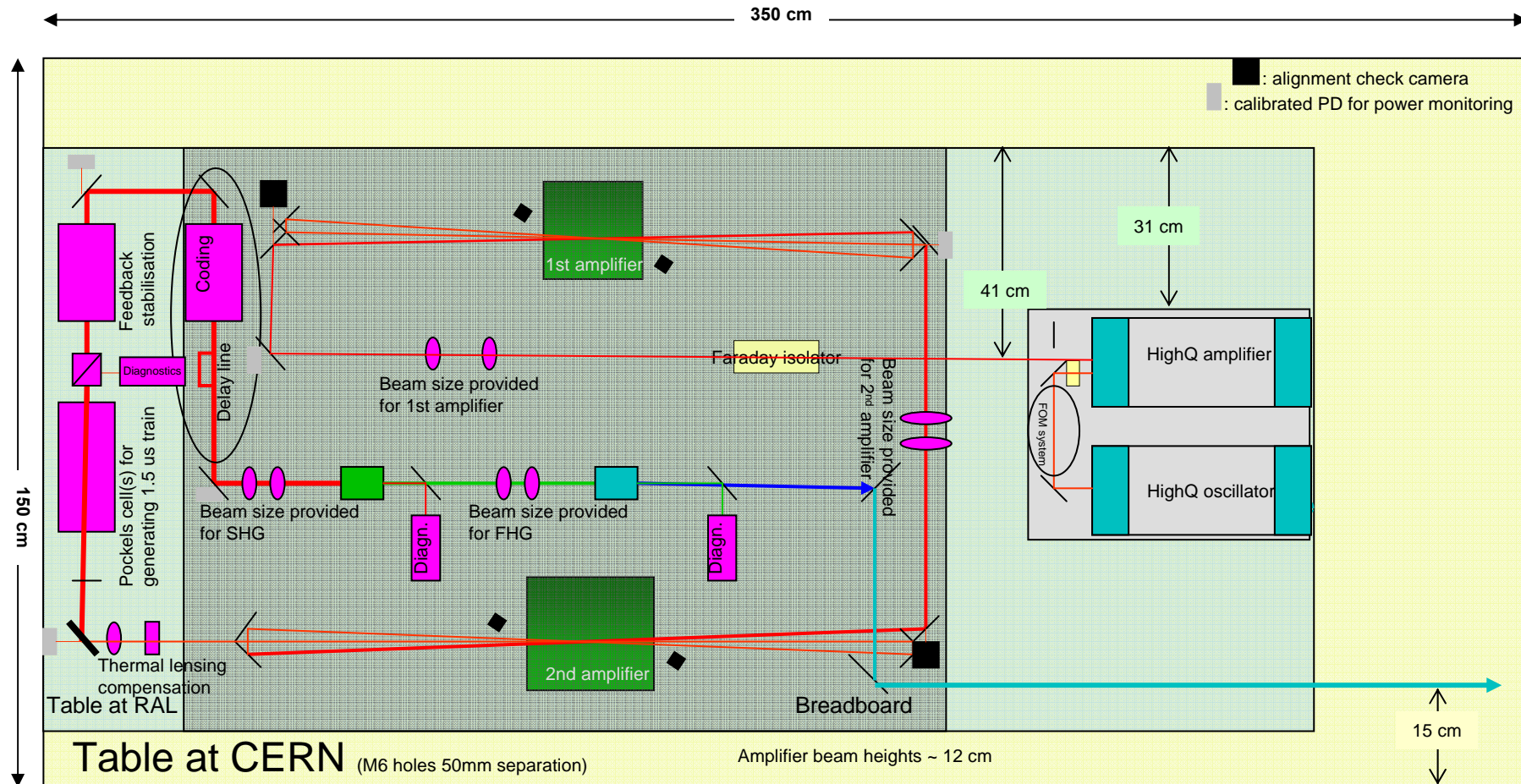




LASER

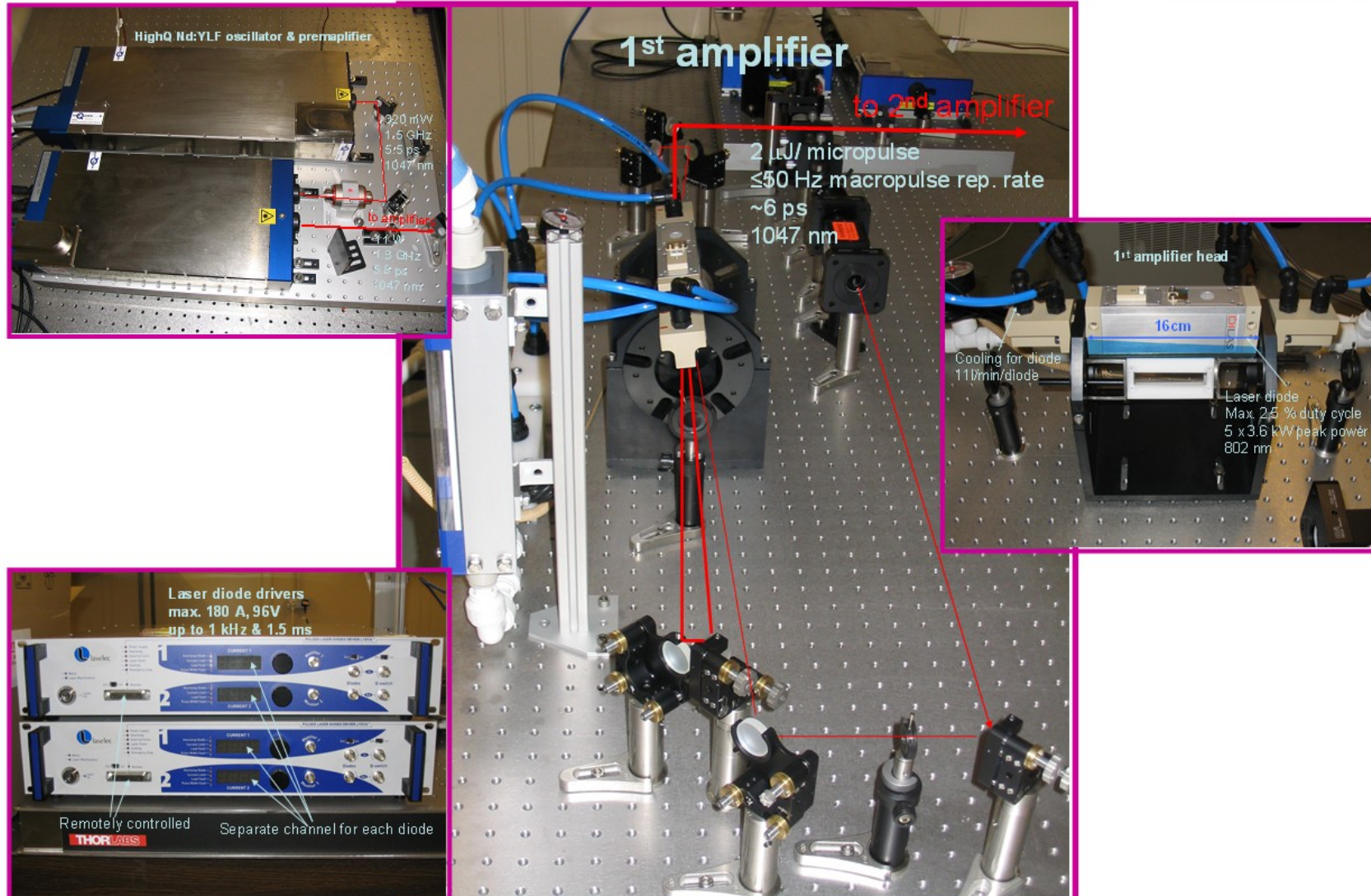
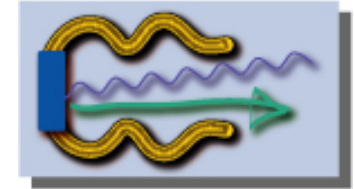


■ How it will look like



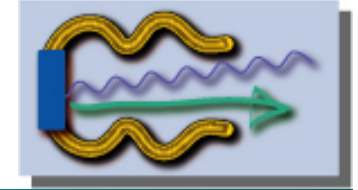


LASER





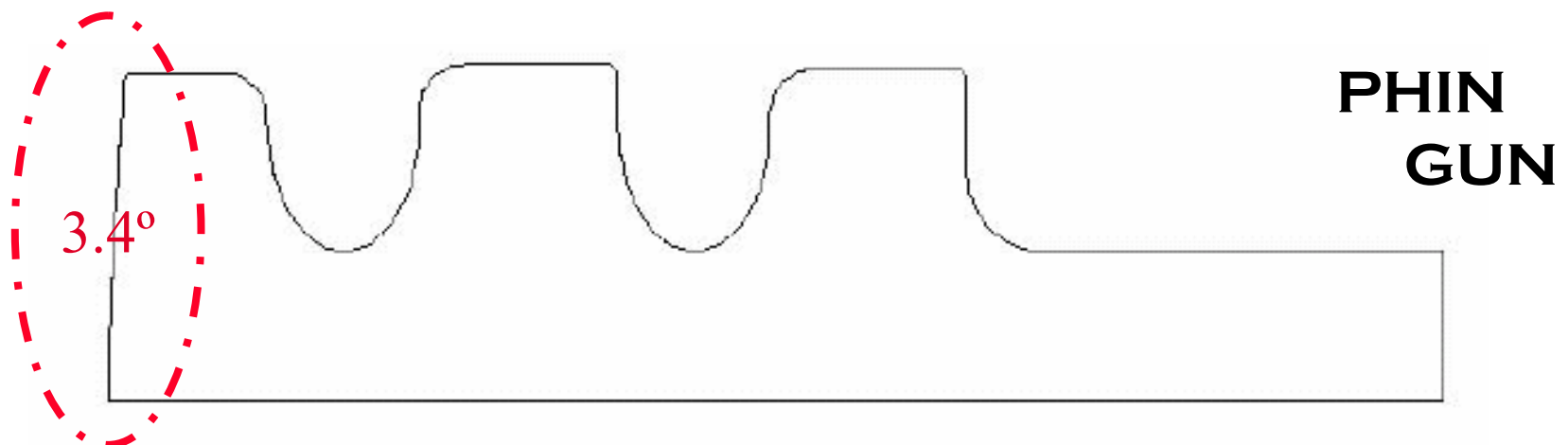
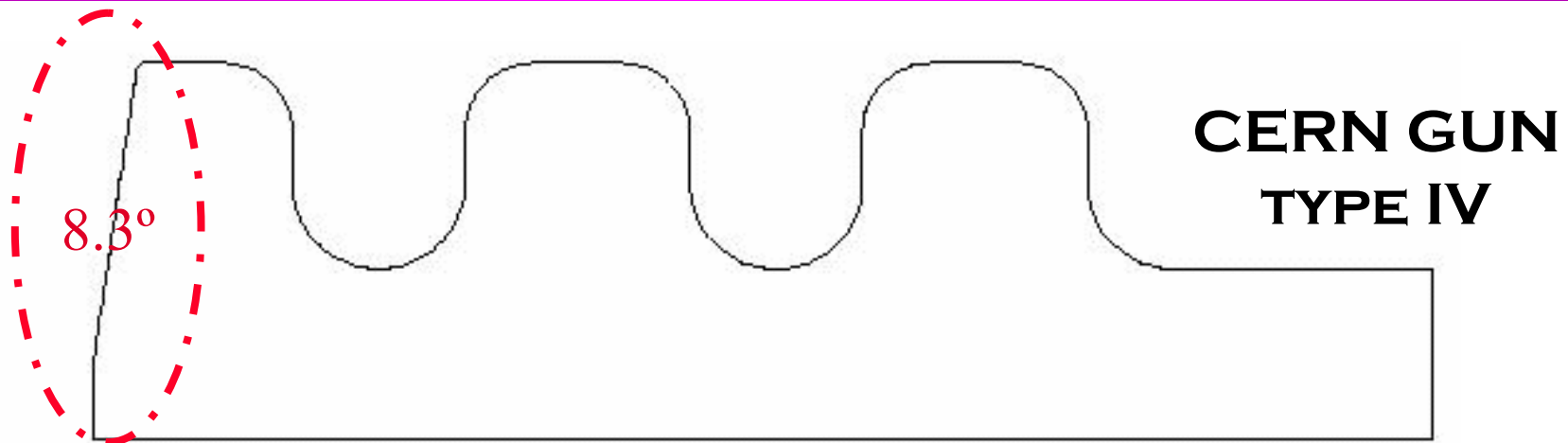
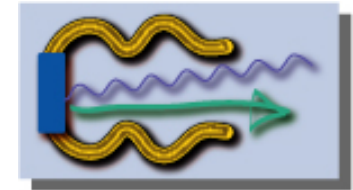
RF Gun



- Design inspired to CTF2 Gun type IV, but ended on a completely new gun.
- Optimization for higher charge, lower emittance, lowest possible vacuum level ($2 \cdot 10^{-10}$ mbar)

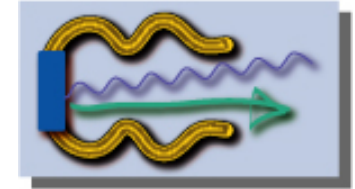


RF Gun





RF GUN

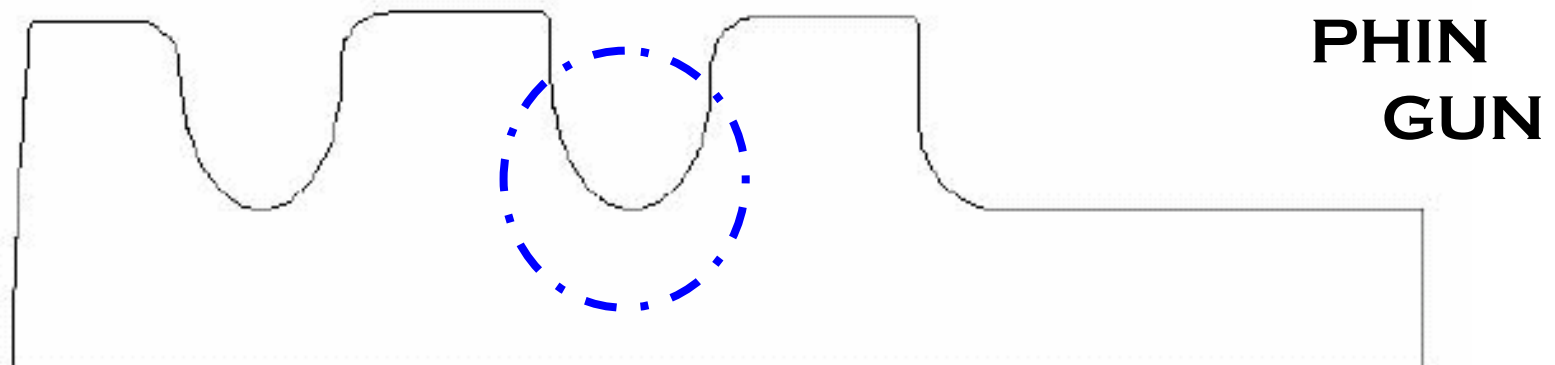
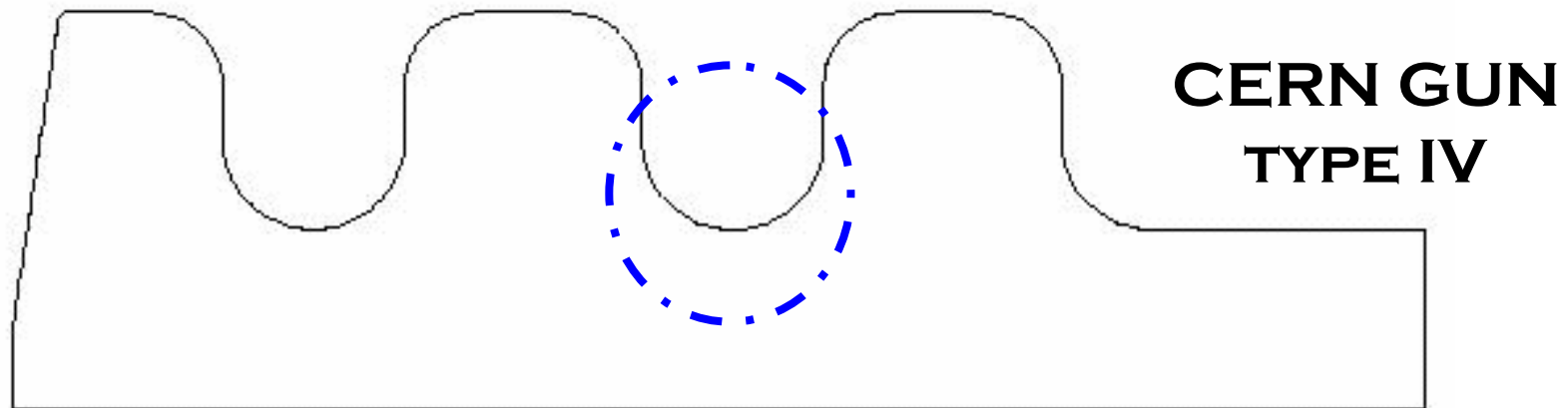
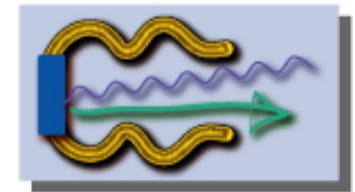


- Effect of cathode wall angle

	0°	3.4°	8.3°
σ_x (mm)	3.4	3.25	3.04
ε_T (π mm-mrad)	20.6	20.7	22.3
σ_z (mm)	1.11	1.15	1.2
$\frac{\Delta p}{p}$ (%)	0.6	0.75	2.6

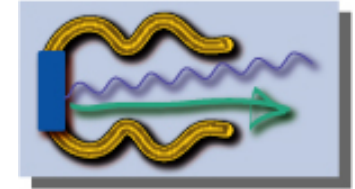


RF Gun

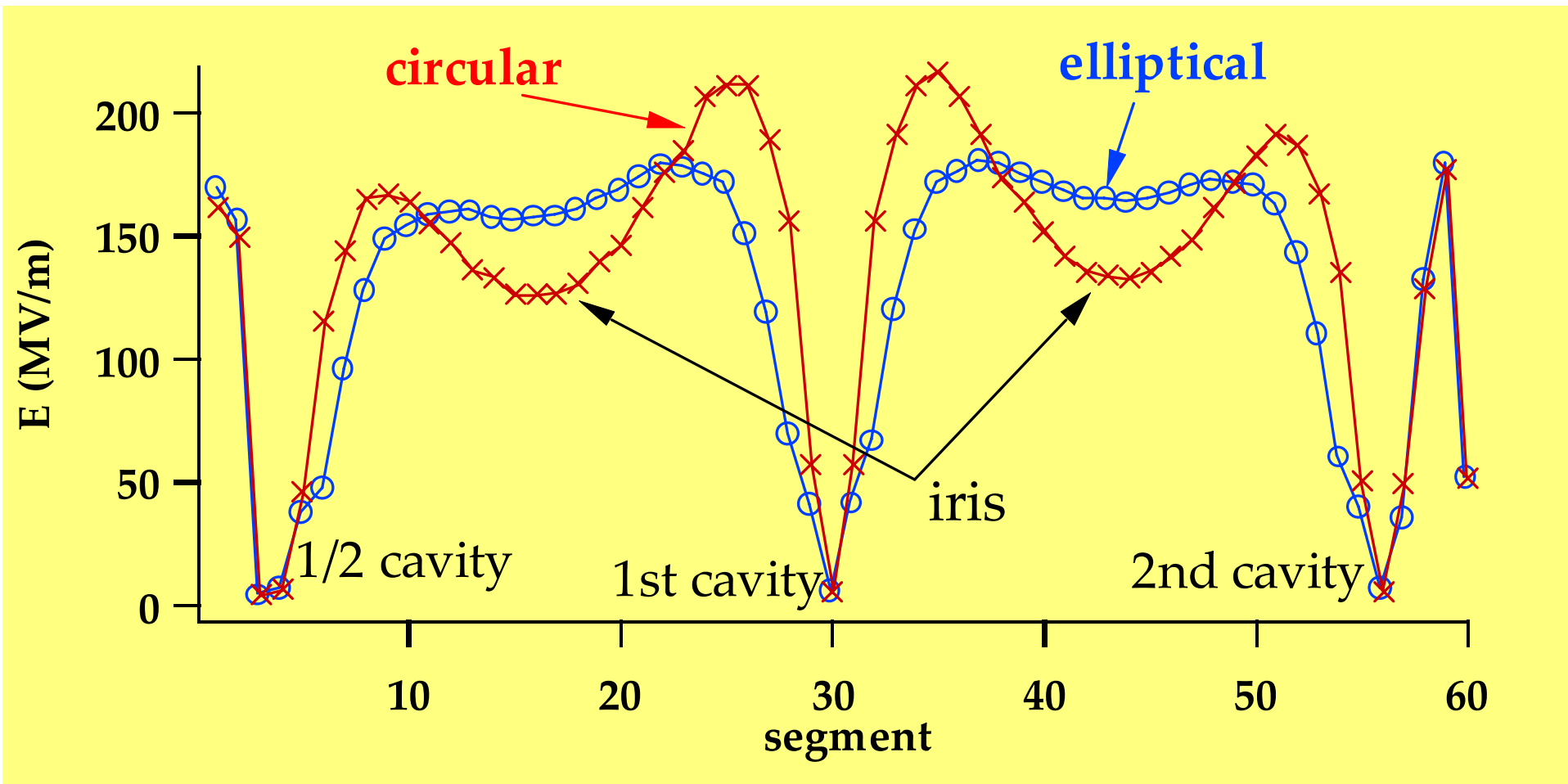




RF GUN

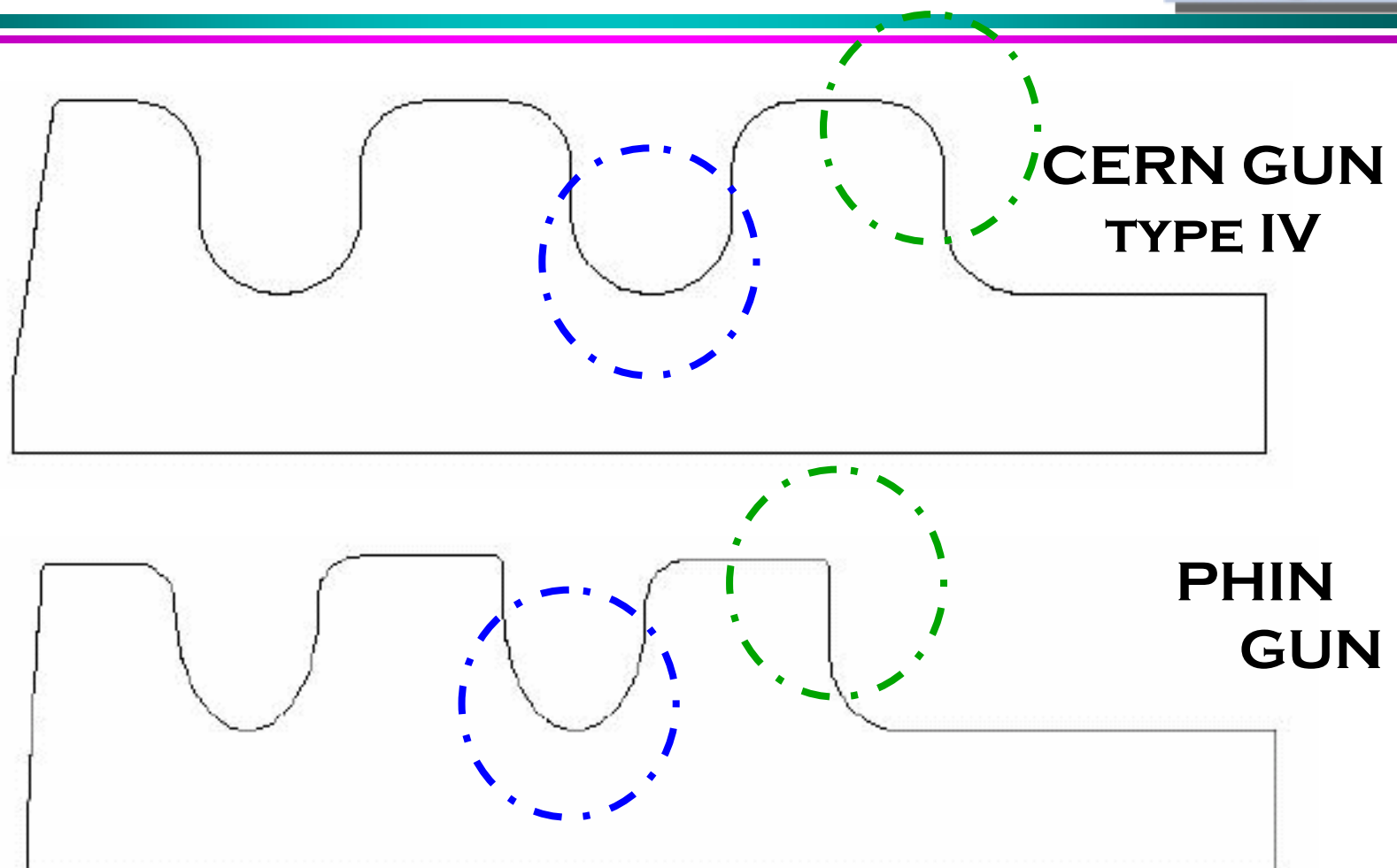
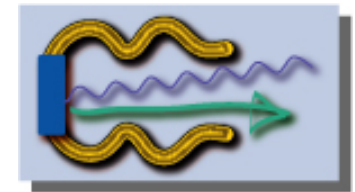


■ Effect of Iris Shape



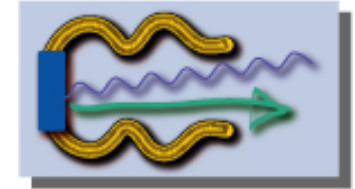


RF Gun

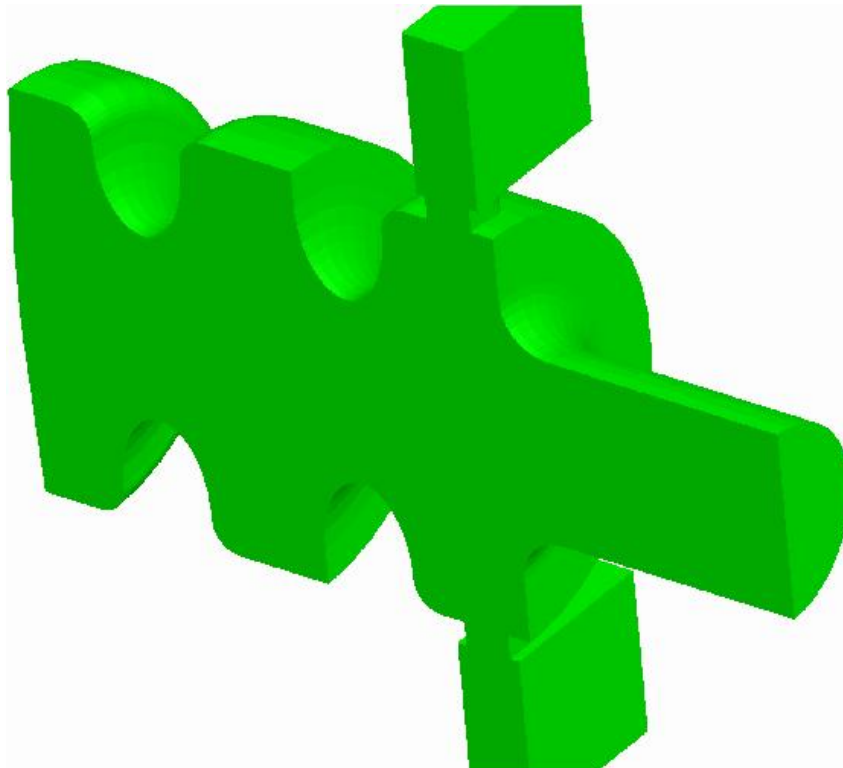




RF Gun



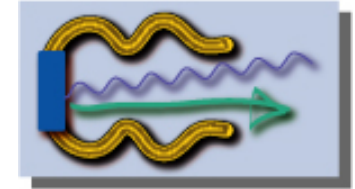
- Next step: 3D Simulations with HFSS



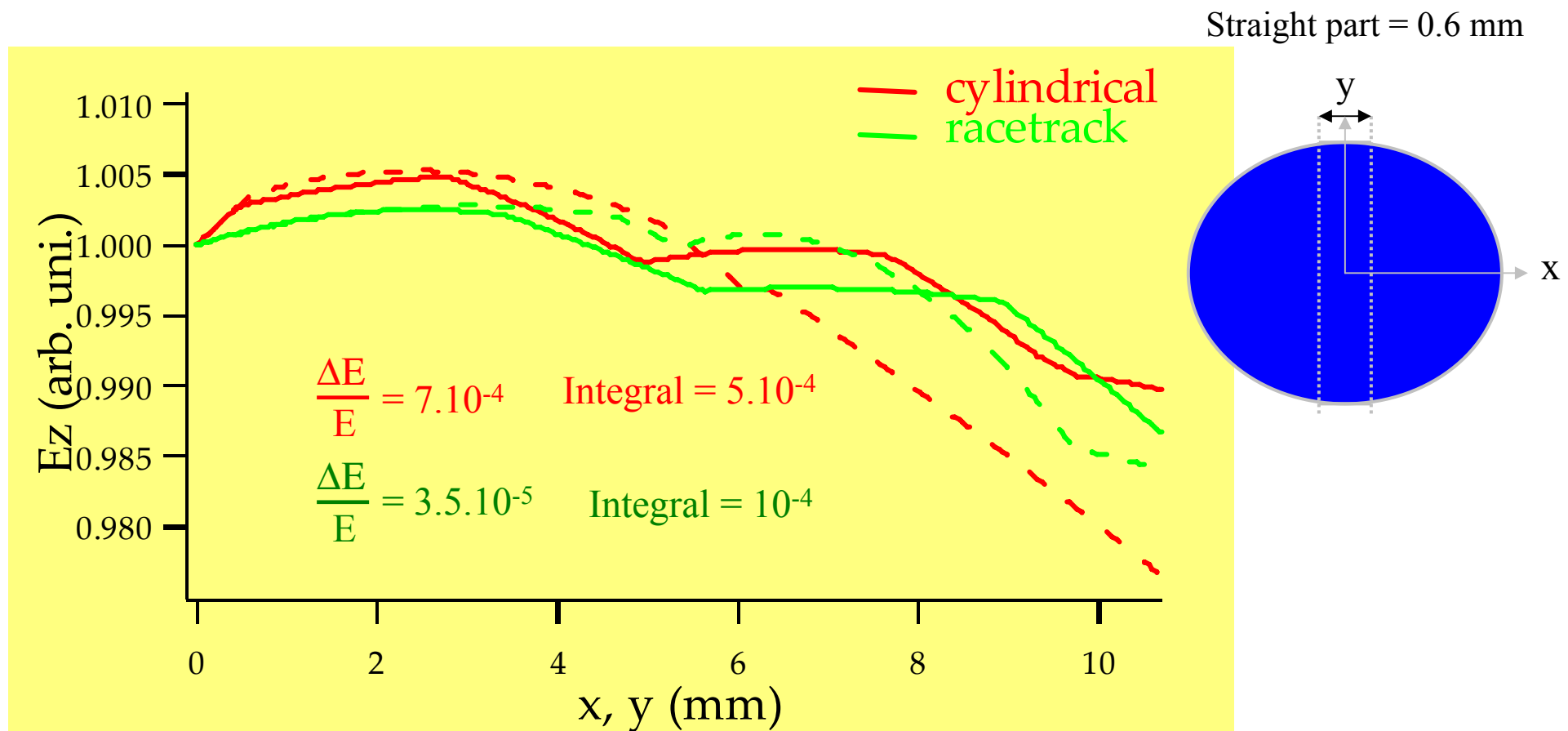
- Two symmetric couplers to reduce transverse kick
- Overcoupled ($\beta=2.9$) to match the beam.
- 30 MW are needed to compensate beam loading



RF Gun

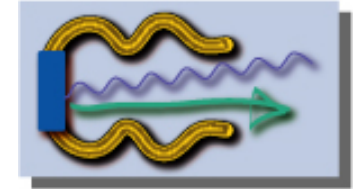


- An idea to symmetrise the fields: Racetrack shape for cell iris (Haimson)

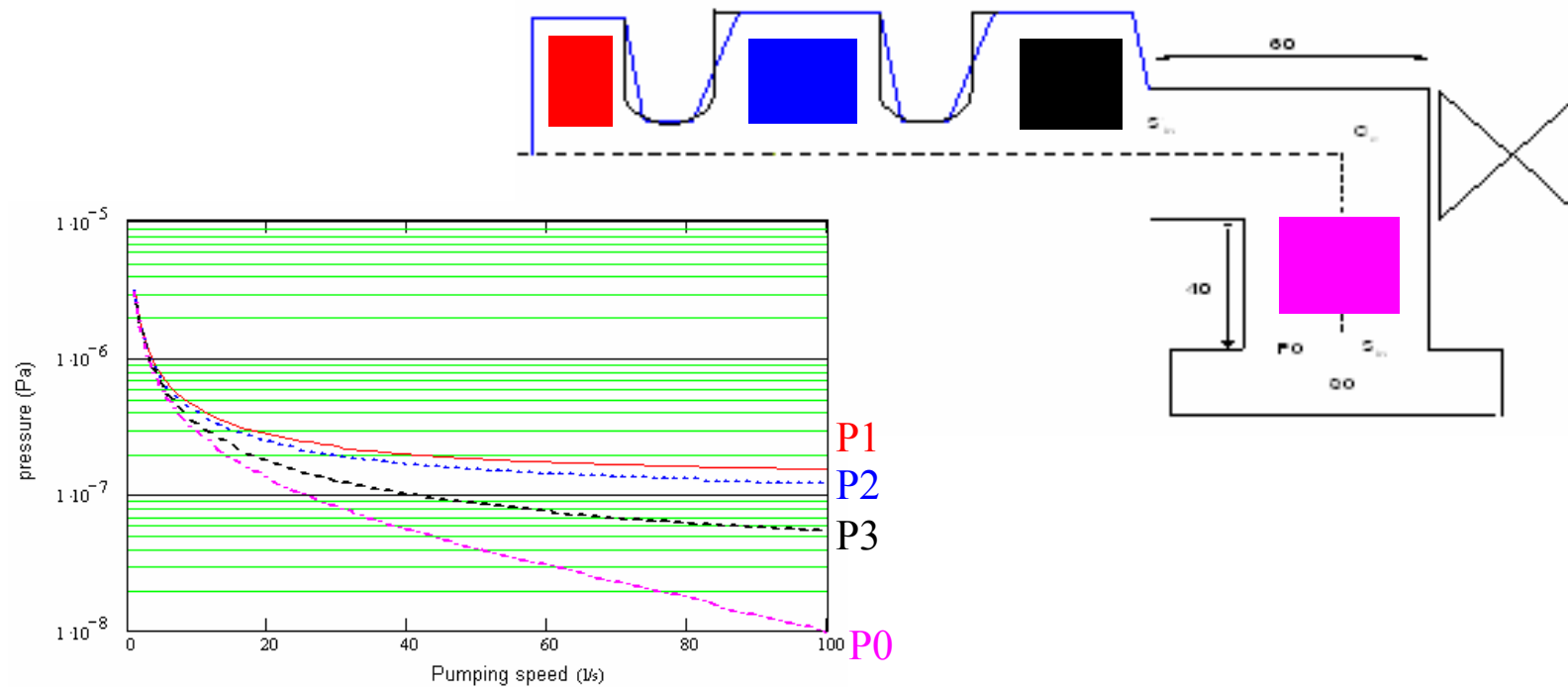




RF Gun



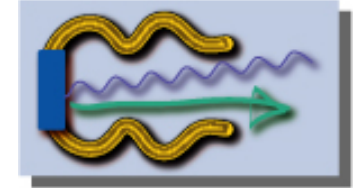
Monte-Carlo based simulations of the residual pressure



- Useless above 40 l/s
- Weak help of a supplementary pumping



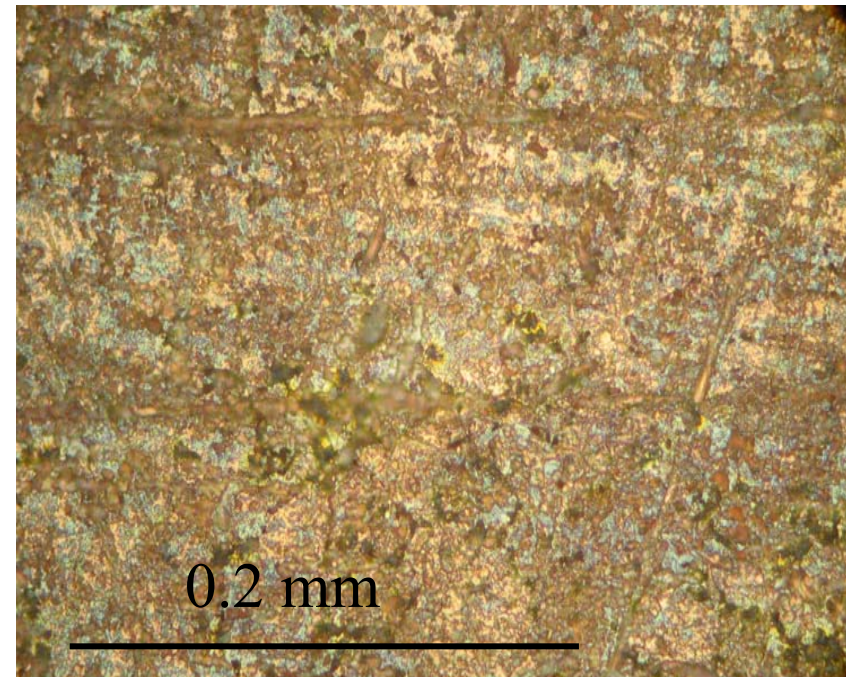
RF Gun



Improvement of static pressure:
minimize the out-gassing rate by High temperature bake

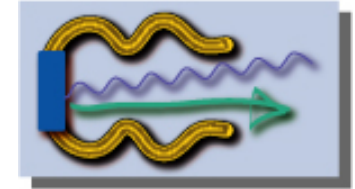
Copper in oven 3 days, $t^\circ = 550^\circ\text{C}$
Fast cooling with Ar jet 150°C
=>No grain size enhancement

- Thanks to the high T bake-out
The residual pressure from copper
outgassing should be reduced by at
least one order of magnitude
(down to 10^{-10} mbar)

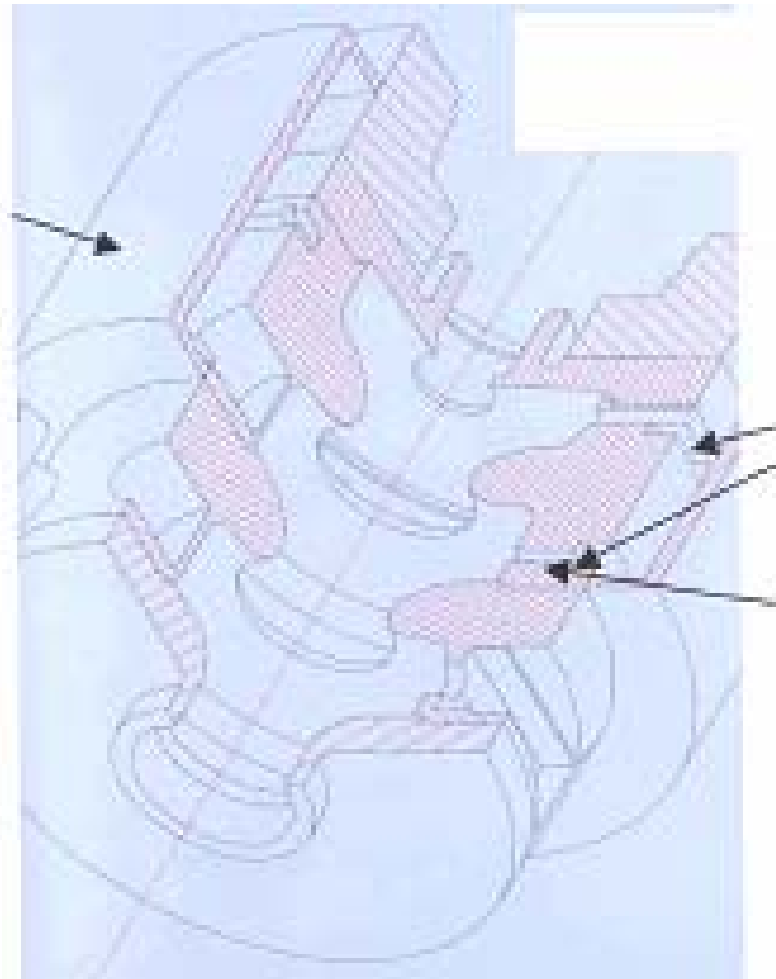
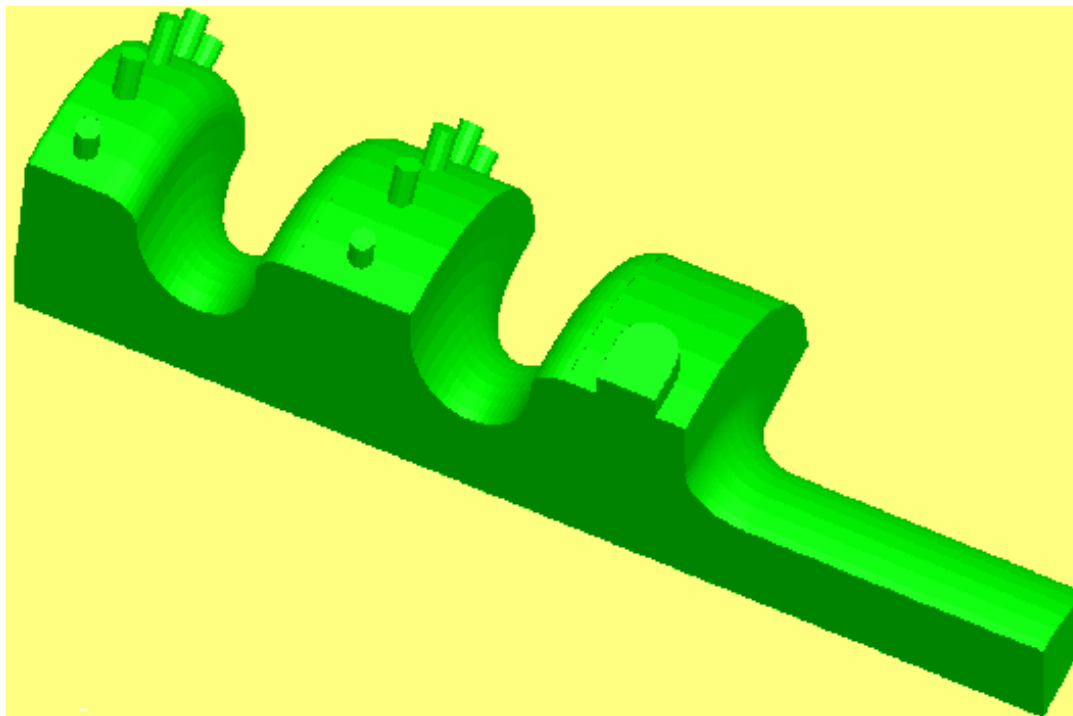




RF Gun

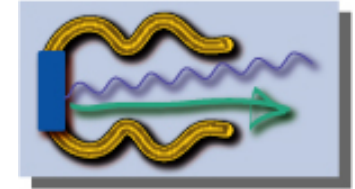


42 holes drilled in the gun walls ($\Phi=4\text{mm}$)
Volume around the holes coated with NEG

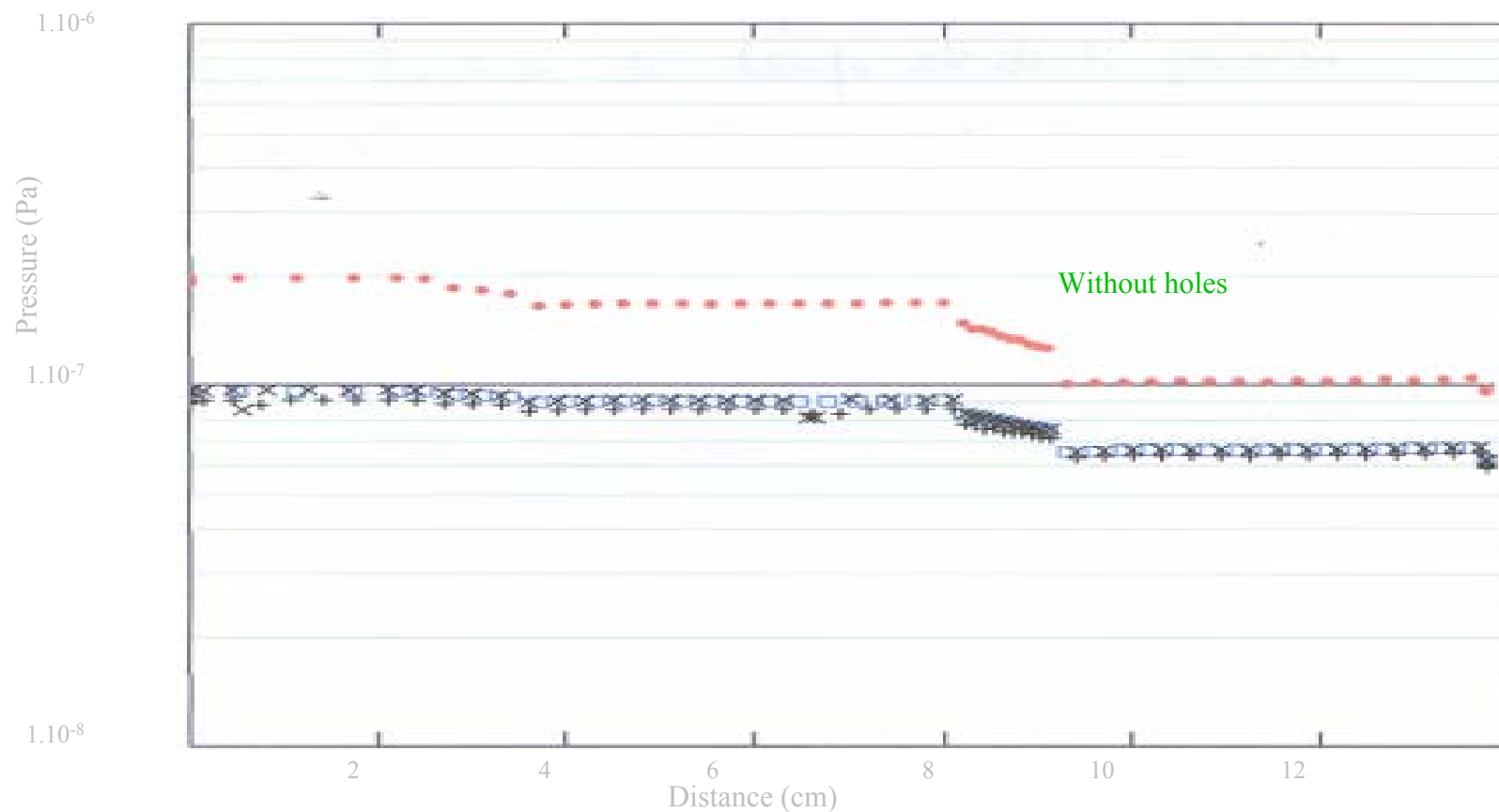




RF Gun

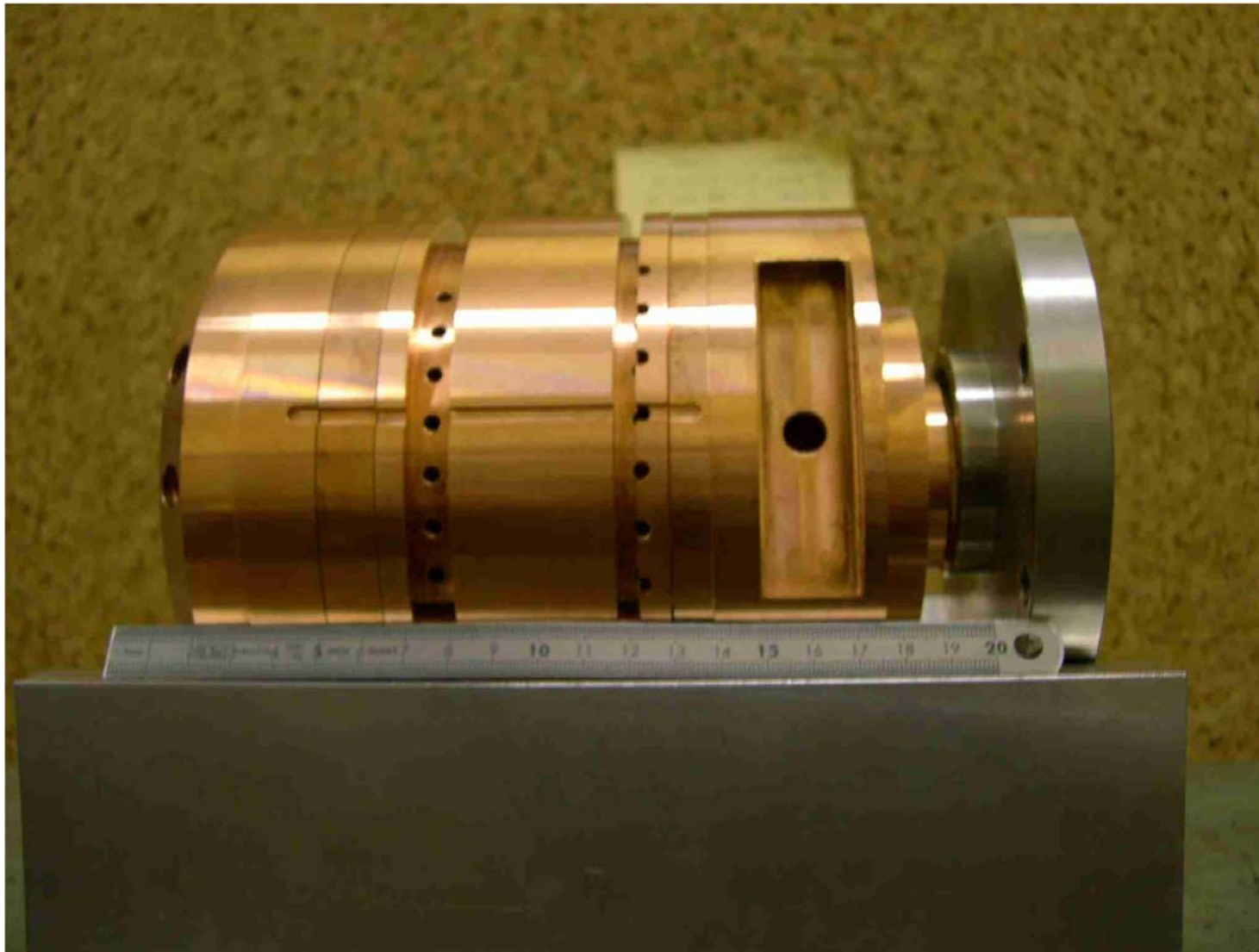
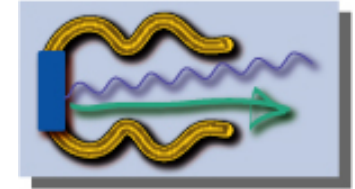


Improvement of static and dynamic pressure:
Drill holes in the cells and deposit a NEG film in the volume outside



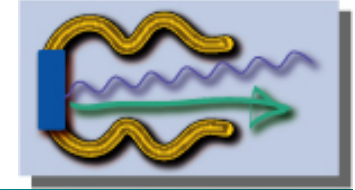


RF Gun





Photocathodes

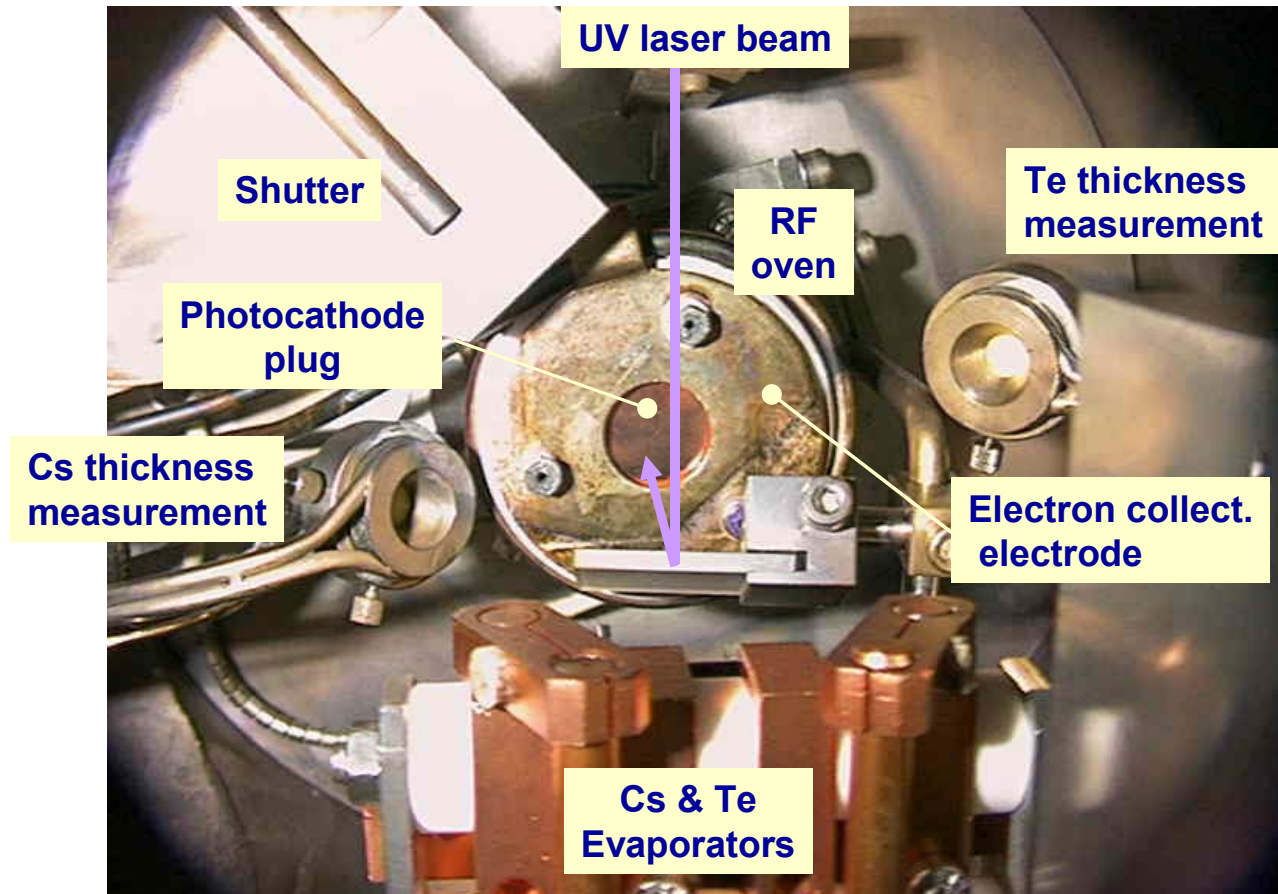
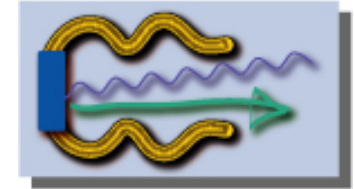


- CERN photocathode Lab was working without interruption since 15 years.
- The whole line (preparation chamber, DC Gun, transport carrier) has been inspected and repaired.
- We started again few days ago with the first calibration coatings.
- We will start very soon with production of CsTe_2 by co-evaporation





Photocathodes

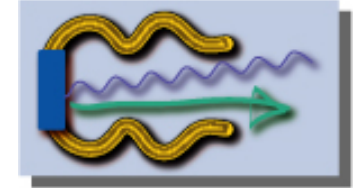


20 cath.	QE(%)
Min	8.2
Average	14.9
Max	22.5

Difficult thickness measurements and poor reproducibility



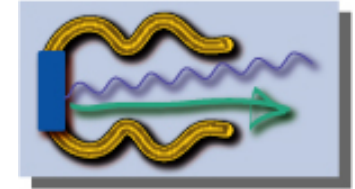
Photocathodes



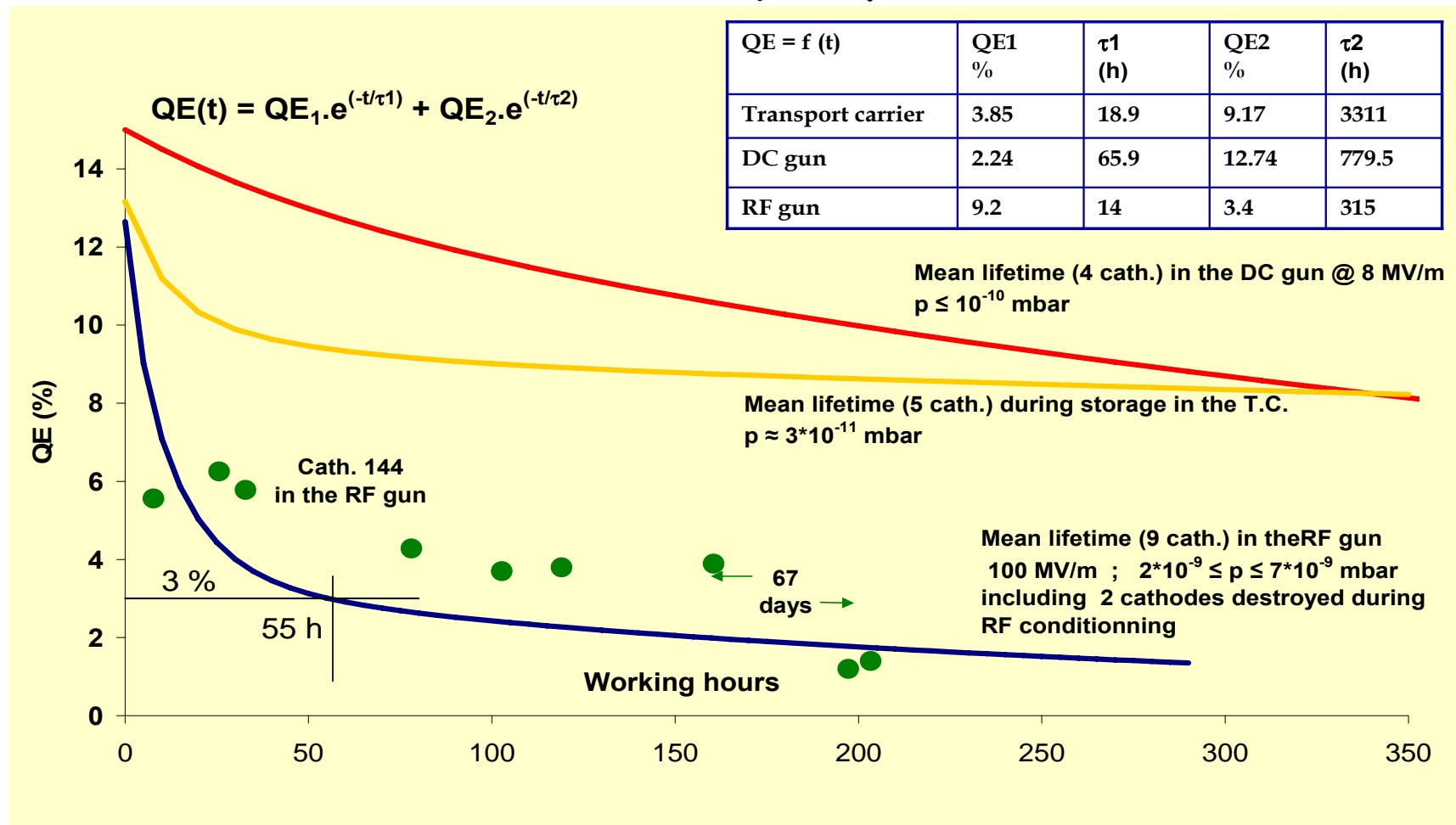
- Improvement of Cs-Te cathode production (standard cathodes for CTF3)
- Co-evaporation : thickness calibration → **evaporation rate control** → stoichiometric ratio control
 - ◆ New evaporators : CEA's oven
 - ◆ New control system: VME based
 - ◆ Improved vacuum pressure measurement and new rest gas analysis
 - ◆ New transfer arm for XPS analysis



Photocathodes

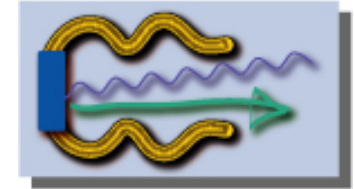


- But photocathodes produced by co-evaporation seem to be more sensitive to the vacuum quality

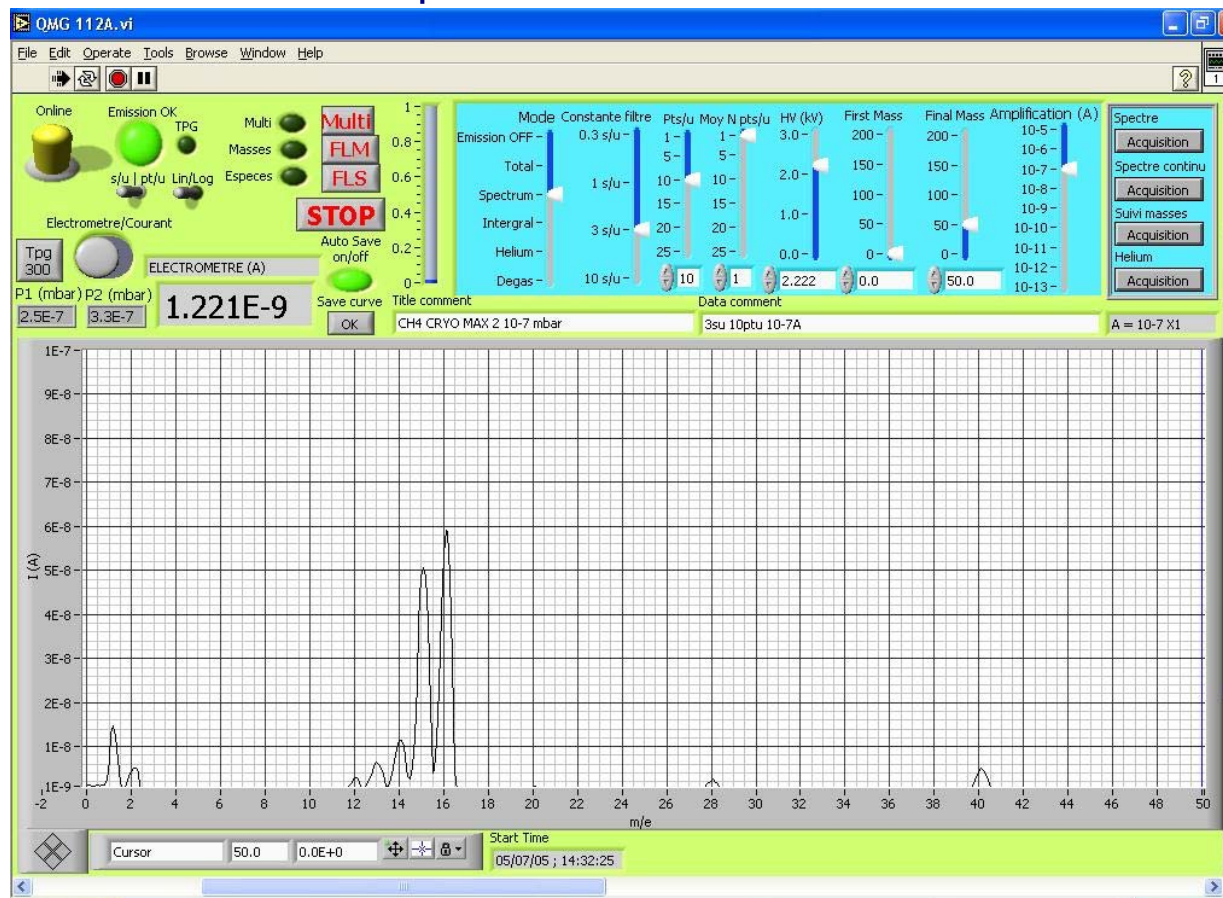




Photocathodes

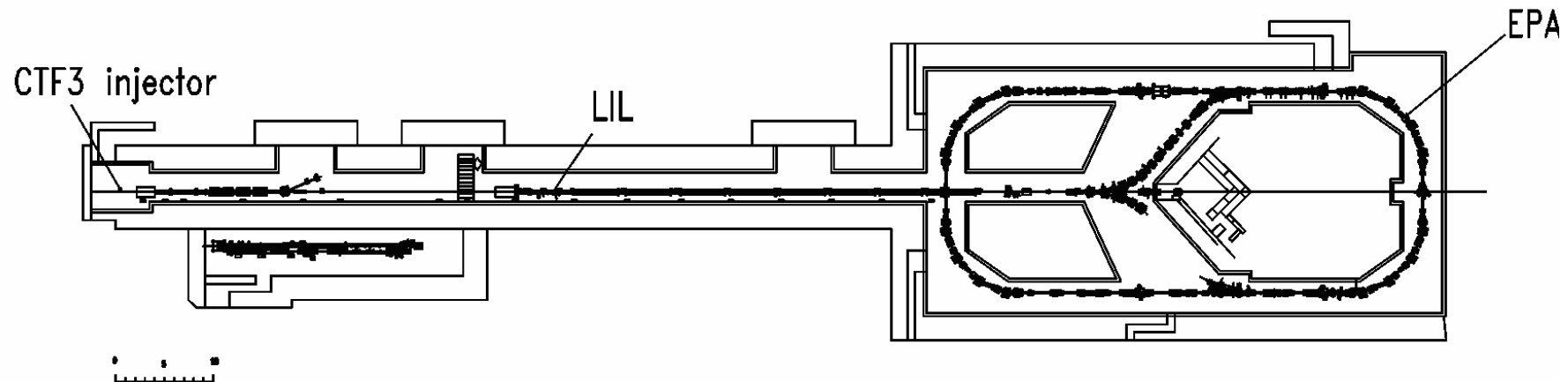
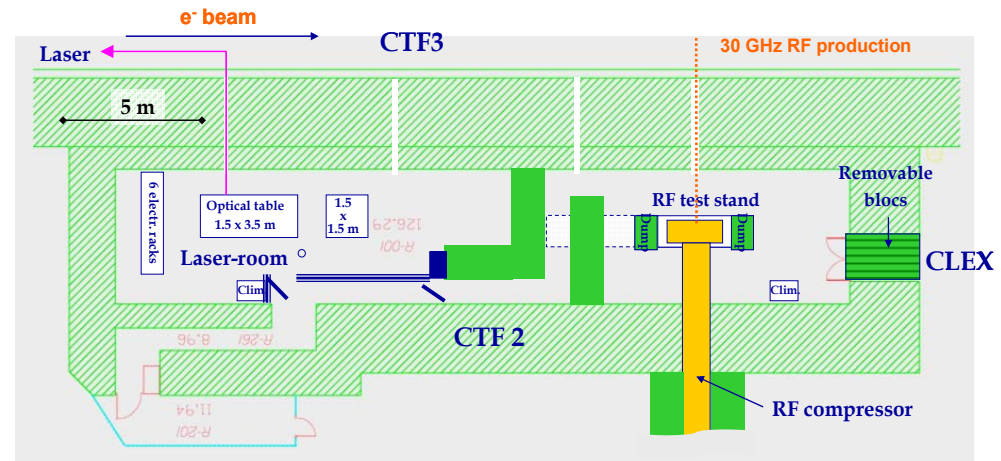
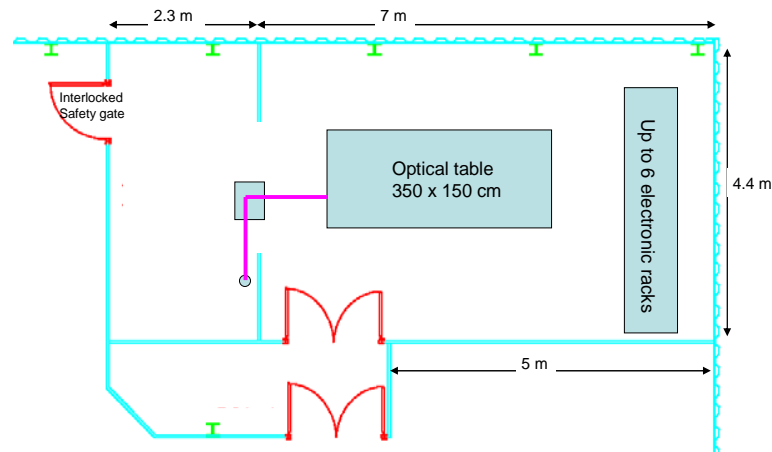
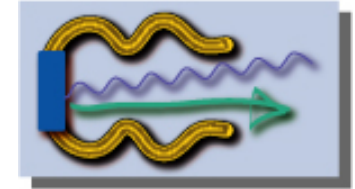


- Rest gas analysis by mass spectrum analyzer: spectrum of CH_4



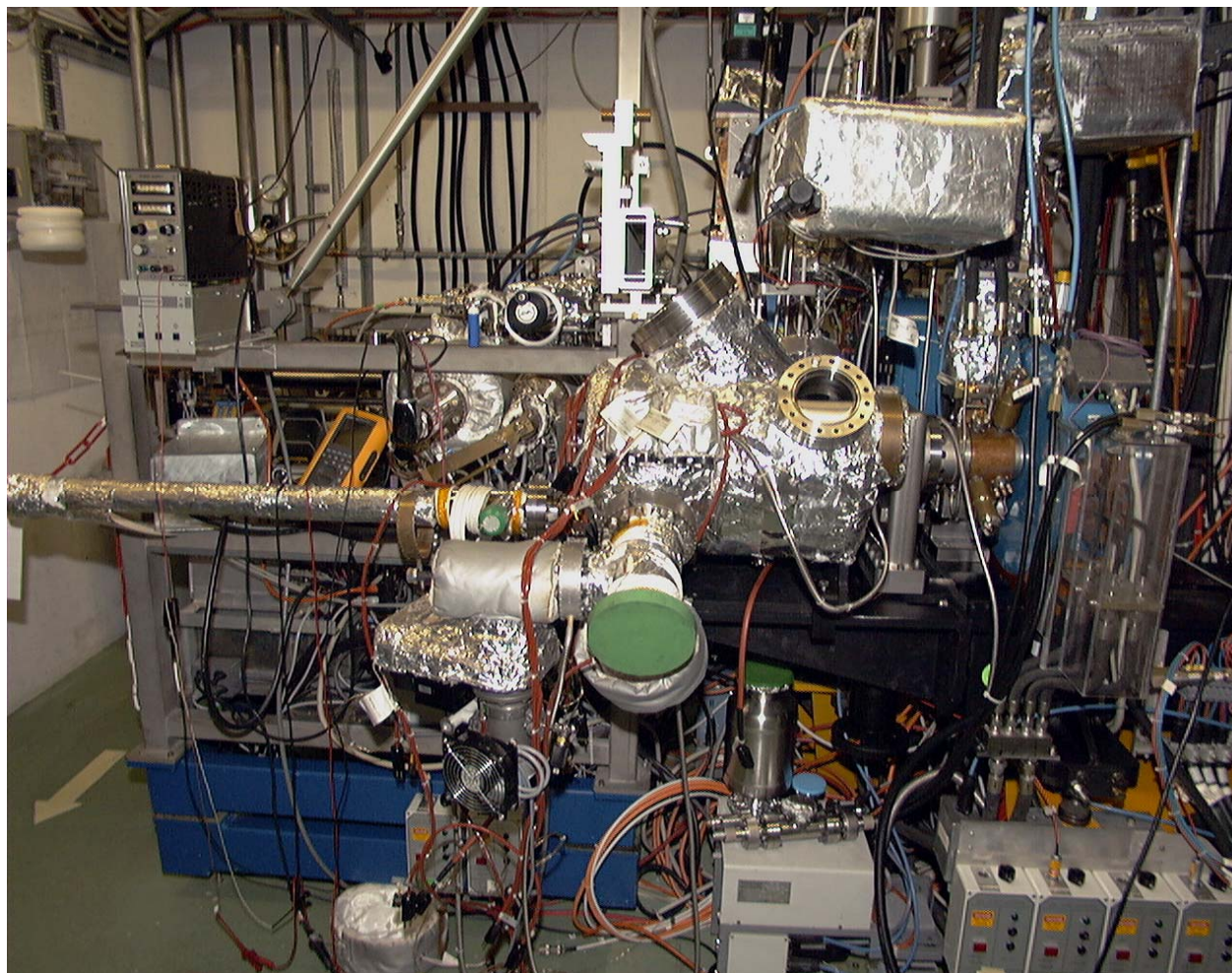
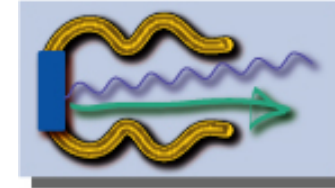


Putting All Together



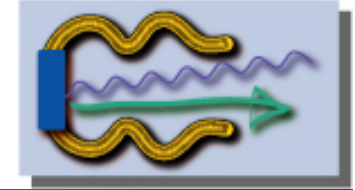


Putting All Together





Conclusions



- Design Phase is concluded, both for the Gun and the Laser
- A solid solution for photocathodes already exists, we will try to improve the reproducibility
- Laser is expected at CERN by May 2006
- The RF Gun is expected by August 2006
- The first beam is for Care '06